



ELECTRONIC COPY

LG791614981
Report verification at igi.org



April 14, 2026

IGI Report Number **LG791614981**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **11.29 X 11.09 X 7.47 MM**

GRADING RESULTS

Carat Weight **8.17 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

April 14, 2026
IGI Report Number **LG791614981**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **PRINCESS CUT**
Measurements **11.29 X 11.09 X 7.47 MM**

GRADING RESULTS

Carat Weight **8.17 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

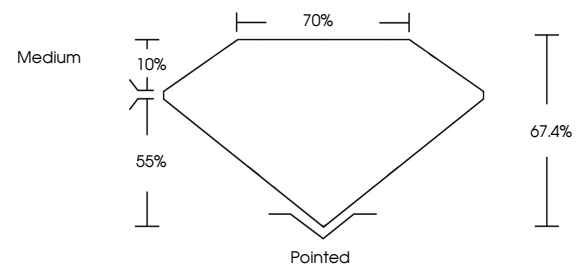
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG791614981**

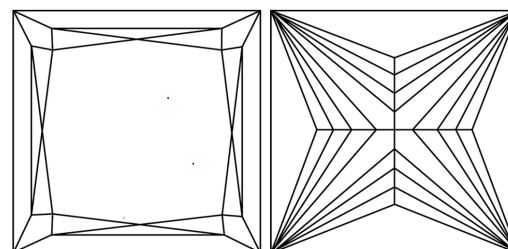
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

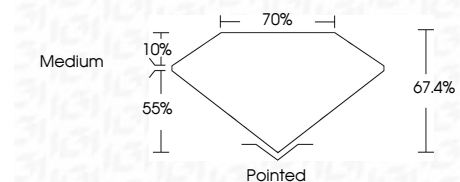
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG791614981**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI



April 14, 2026
IGI Report No LG791614981
PRINCESS CUT
11.29 X 11.09 X 7.47 MM
8.17 CARATS
Color Grade **E**
Clarity Grade **VVS 2**
Depth **67.4%**
Table **70%**
Girdle **Medium**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG791614981**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa